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**CONFIRMATION NO. 1115** 

Brent A Anderson, Jericho, VT; Edward J Nowak, Essex Junction, VT; BethAnn Rainey, South Burlington, VT;  **CONTINUING DATA***  **FOREIGN APPLICATIONS***  **FREQUIRED, FOREIGN FILING LICENSE GRANTED**  **90/05/2003**  **Oreign Priority claimed**  **SUSC 119 (a-d) conditions met											
Brent A Anderson, Jericho, VT; Edward J Nowak, Essex Junction, VT; Bethann Rainey, South Burlington, VT; CONTINUING DATA  F REQUIRED, FOREIGN APPLICATIONS  FOREIGN APPLICATIONS  FOREIGN APPLICATIONS  FOREIGN APPLICATIONS  FOREIGN FILING LICENSE GRANTED  OgoloSizolo3  Foreign Priority claimed  State OR  STATE OR  SHEETS  TOTAL  INDEPENDENT  COUNTRY  DRAWING  CLAIMS  20  ADDRESS  23550  HOFFMAN WARNICK & D'ALESSANDRO, LLC  75 STATE STREET  14TH FLOOR  ALBANY, NY  12207  TITLE  METHOD OF FORMING FREESTANDING SEMICONDUCTOR LAYER  FILING FEE  FEES: Authority has been given in Paper  No to charge/credit DEPOSIT ACCOUNT  No for following:  Other  Oth		SERIAL NUMBER 06/26/2003 10/604,116		'				NO.			
Edward J Nowak, Essex Junction, VT; BethAnn Rainey, South Burlington, VT;  "CONTINUING DATA"  "FOREIGN APPLICATIONS"  "FOREIGN APPLICATIONS"  "FOREIGN FILING LICENSE GRANTED"  "90/90/5/2003  Foreign Priority claimed  IS USC 119 (a-d) conditions met latter Asswance  Sousc 119 (a-d) conditions met latter Asswance  COUNTRY DRAWING CLAIMS  ADDRESS  23550  ADDRESS  235	APPLICANTS										
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